


<b>Search Notes</b> 	<b>Application/Control No.</b> 10748950	<b>Applicant(s)/Patent Under Reexamination</b> IKEDA, ROGER M.
	<b>Examiner</b> Koziol, Stephen R	<b>Art Unit</b> 2624

SEARCHED			
Class	Subclass	Date	Examiner
382	168	4/21/2008	SRK
345	108	4/21/2008	SRK

SEARCH NOTES		
Search Notes	Date	Examiner
Further text search for adjusting aperture movement rate	4/21/2008	SRK

INTERFERENCE SEARCH			
Class	Subclass	Date	Examiner